

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2815
Shunpei YAMAZAKI et al.	)	Examiner: Jerome Jackson, Jr.
Serial No. 10/084,935	)	CERTIFICATE OF MAILING  I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450,
Filed: March 1, 2002	)	
For: INSULATING FILM AND METHOD	)	
OF PRODUCING SEMICONDUCTOR	)	Alexandria, VA 22313-1450, on December 17, 2007.
DEVICE	)	adile on Stanger
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## <u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 16, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.